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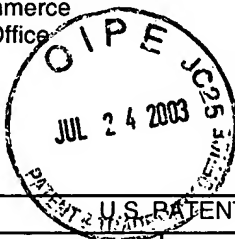
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## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KM	<u>Laser Engineered Net Shaping (LENSTM): A Tool for Direct Fabrication of Metal Parts</u> , Clint Atwood, Michelle Griffith, Lane Harwell, Eric Schlienger, Mark Ensiz, John Smugersky, Tony Romero, Don Greene, Daryl Reckaway, LENSTM Project Team, Sandia National Laboratories, Proceedings of ICALEO '98, November 16-19, 1998, Orlando, FL, p. E-1.
KM	<u>Laser Engineered Net Shaping</u> , Michelle Griffith & David Gill, Sandia National Laboratories.
KM	<u>Laser Consolidation - A Novel One-Step Manufacturing Process from CAD Models to Net-Shape Functional Components</u> , Lijue Xue & Mahmud-UI Islam, Integrated Manufacturing Technologies Institute, National Research Council of Canada. Proceedings of the 2002 International Conference on Metal Powder Deposition for Rapid Manufacturing, pages 61 - 68. Compiled by David Keicher, James W. Sears, John E. Smugersky.
KM	<u>Laser Direct Manufacturing Research at Lockheed Martin</u> , Brian T. Rosenberger, Lockheed Martin Aeronautics Company. Presentation given at the MPIF Rapid Manufacturing Seminar: Laser and Powder Based Technologies, October 23-24, 2000, Providence RI.
KM	<u>The Influence of Processing Parameters on the Formation of Pores and Columnar Grains in Laser Deposited Ti-6Al-4V Alloy</u> , Paul S. Goodwin, Carolyn Mitchell, Jing Liang, Junfa Mei, & Xinhua Wu, QinetiQ. Proceedings of the 2002 International Conference on Metal Powder Deposition for Rapid Manufacturing, pages 87 - 95. Compiled by David Keicher, James W. Sears, John E. Smugersky.

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